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Thermodynamic Investigation of the Si7 and Si8 Clusters by Knudsen Cell Mass Spectrometry

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Thermodynamic investigation of the Si$_7$ and Si$_8$ clusters by Knudsen cell mass spectrometry

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The Knudsen cell mass spectrometric method has been employed to measure the partial pressures of the Si$_7$ and Si$_8$ clusters under equilibrium conditions above liquid silicon, contained in a boron nitride liner inside a graphite Knudsen cell. Gaussian 2 (G2) theory and B3LYP density functional method were employed to determine the geometry, the vibrational frequencies, and the binding energy of the Si$_n$ cluster. From the all-gas analyzed equilibria the following atomization enthalpies, $\Delta_a H^0(Si_n)$, and enthalpies of formation, $\Delta_f H^0_{298.15}(Si_n)$, in kJ mol$^{-1}$, have been obtained: Si$_7$, 2381$\pm$36 and 743$\pm$36; Si$_8$, 2735$\pm$65 and 837$\pm$65. Experimental literature values for the electron affinities of Si$_n$($n=3$–8) have been combined with present and previous results to obtain the bonding energies for the Si$_n$$^-$ ($n=3$–8) cluster anions. The experimental atomization energies are compared with available theoretical values. © 2001 American Institute of Physics. [DOI: 10.1063/1.1391265]

I. INTRODUCTION

Investigations of the structures, energetics, and reactivities of atomic clusters have attracted a significant interest in recent years. Occupying the intermediate position between the separate atoms and condensed matter, atomic clusters have been studied to develop new approaches in catalysis and in thin film technology, and to explain phenomena such as nucleation processes$^1$ and crystal growth at the molecular level. Furthermore the deposition of size-selected atomic clusters on surfaces is of special interest, justified by the belief that it may be possible to preserve, and thus investigate, some of the peculiar size-dependent properties of the corresponding free clusters.$^{2,3}$

Silicon has dominated the semiconductor industry for a long time thanks to its superior electric properties. More recently, silicon is also becoming an interesting material for photonic applications$^4$ as a consequence of its photoluminescence and electroluminescence properties.$^5,6$ In fact, low dimensional silicon structures show quantum size effects which can greatly alter the properties of the bulk giving rise to a new generation of electronic devices.$^7$

The first mass spectrometric observation of silicon clusters has been by Honig$^8$ who measured the ion currents for Si$^+$ through Si$_7^+$ above silicon contained in an open beryllia crucible at temperatures of 1400–1660 K. Silicon clusters and cluster ions have been extensively studied since the 1980s$^9$–$^{11}$ when new cluster production techniques started to be employed. A considerable effort has been devoted to the determination of the structures of silicon clusters and the largest cluster with experimentally confirmed geometry is Si$_{12}$, a pentagonal bipyramid with a $D_{5h}$ symmetry.$^{12$–$16}$

Small silicon clusters have been investigated employing several theoretical approaches, such as quantum chemistry methods,$^{17$–$25}$ tight-binding methods,$^{26$–$33}$ calculations based on molecular dynamics methods,$^{34$–$43}$ on space-fixed genetic algorithms,$^{44,45}$ on interatomic potential functionals,$^{46}$ on orbital-free kinetic-energy functionals,$^{47}$ and on variational fixed-node diffusion Monte Carlo methods.$^{48}$

Many experimental techniques have been employed to study the properties of silicon clusters.$^{12$–$16,49$–$55}$ Honea et al.$^{12,16}$ reported the structures of size-selected silicon clusters using surface-plasmon-polariton (SPP) enhanced Raman spectroscopy. Jarrold and co-workers$^{49,50}$ measured the mobilities of size-selected silicon clusters ions, produced by pulsed laser vaporization of a silicon rod, for their structural characterization. Trevor et al.$^{51}$ and Fuke et al.$^{52}$ examined the photoionization thresholds of silicon clusters by laser photoionization with detection by a time-of-flight mass spectrometer. Cheshnovsky et al.$^{53}$ measured anion ultraviolet photoelectron spectra (UPS) of Si$_n$$^-$ ($n=12$) clusters, yielding electron affinities estimates and a qualitative description of the HOMO-LUMO gap. Neumark and co-workers$^{54,55}$ measured photoelectron spectra of Si$_n$$^-$ ($n=3$–7) clusters at several photodetachment energies, obtaining electronic states, accurate electron affinities, term energies, and vibrational frequencies for the ground state and for excited electronic states of neutral clusters. Bachels and Schäfer$^{55}$ used a pyroelectric calorimeter in combination with a molecular beam apparatus to investigate the binding energies of isolated neutral silicon clusters.

Knudsen-effusion mass spectrometric measurements have been performed by Chatillon$^{26}$ who evaporated a mixture of silicon and SiC(s) from a glassy graphite cell that was inserted into a tantalum Knudsen cell. He reported second-law enthalpies of formation for Si$_2$–Si$_7$ at the corresponding average temperatures of measurement. Rocabois et al.$^{57}$ used a multiple Knudsen cell device in which four graphite cells are located in the same tantalum block. One of the cells contained the gold used as standard for pressure calibration; the sample of silicon and SiC(s) was evaporated.
from another cell. They reported standard enthalpies of formation, $\Delta H_{298.15}^\circ$, for Si$_2$–Si$_8$.

The present investigation of the Si$_7$ and Si$_8$ clusters is an extension of our previous studies of small silicon clusters, Si$_2$ and Si$_3$,$^{58}$ Si$_4$,$^{59}$ Si$_5$,$^{60}$ and Si$_6$,$^{61}$ and a continuation of our systematic study of thermodynamic properties of small atomic clusters of group 14 elements (Refs. 62–65) by Knudsen cell mass spectrometry. We report our results derived from the mass spectrometric equilibrium data for the atomization enthalpies and enthalpies of formation of Si$_7$ and Si$_8$. New thermal functions were calculated from molecular parameters taken from literature for Si$_7$, or calculated by the Gaussian 2 (G2) theoretical procedure for Si$_8$. Preliminary experimental results from our laboratory have been reported in Ref. 66. The atomization energies of Si$_7$ and Si$_8$ obtained in this investigation are compared to predicted values from theoretical approaches. They have also been used, together with the experimental values for the electron affinities by Xu et al.$^{67}$ for Si$_6$ and Si$_8$, to derive the atomization energies of the corresponding cluster anions.

II. THEORETICAL INVESTIGATIONS

The Gaussian 2 (G2) theoretical procedure together with the density functional (DF) method using the Becke three-parameter exchange functional with the Lee, Yang, and Parr correlation functional (B3LYP) were employed to obtain information of the molecular parameters and binding energy of the Si$_8$ cluster. These calculations were carried out utilizing the GAUSSIAN 98 program package.$^{68}$ We employed the G2 method to obtain a reliable atomization enthalpy for Si$_8$. Raghavachari and Curtiss$^{69}$ have compared experimental values for the atomization energies of small carbon clusters and silicon clusters, obtained in our laboratory, with their G2 values, and have shown good agreement within the error limits of the experimental values.

The G2 theory is the combination of several component calculations. Equilibrium geometries are optimized at the second-order Møller–Plesset perturbation theory (MP2) using the 6-31G(d) basis set with all electrons included, and single-point energies are calculated at the second- and fourth-order Møller–Plesset perturbation theory (MP4) and quadratic configuration interaction [QCISD(T)] levels of theory, using the 6-311G(d,p) and 6-311+G(d,p) basis sets. Harmonic vibrational frequency and the associated zero-point vibrational energies (ZPVE) are calculated at the Hartree–Fock (HF) level. ZPVE and harmonic vibrational frequencies are scaled by 0.893. A double-zeta basis set with a diffuse and polarization function (6-31+G*) was employed for the B3LYP computations.

At both levels of calculations the ground state of Si$_8$ has a $C_{2h}$ $^1A_g$ bicapped octahedral structure. This result agrees with previous computations.$^{19,23,28,29,31,37,39,46}$ Figure 1 shows the Si$_8$, optimized $C_{2h}$ geometry. The optimized bond lengths and vibrational frequencies, together with the zero point energy (ZPE), computed in this investigation are reported in Table I. The bond lengths calculated at the MP2/6-31G* and the B3LYP/6-31+G* levels of theory are almost the same.

The two lowest $a_u$ and $a_g$ normal vibrational modes calculated at the B3LYP/6-31+G* level of theory differ substantially from those calculated by the HF/6-31G* level of theory, but the corresponding zero point energies agree within 1 kJ mol$^{-1}$. The HF/6-31G* vibrational frequencies computed here are the same as those reported by Raghavachari and Rohlfing.$^{19}$ The binding energy of the Si$_8$ cluster was calculated at the B3LYP/6-31+G*, G2(MP2), and G2 levels of theory and the results are reported in Table II. There is good agreement between the G2(MP2) and G2 values, whereas the B3LYP/6-31+G* atomization value is about 300 kJ mol$^{-1}$ smaller than the G2 value. This is due to the underestimation of the binding energy for this functional.

III. EXPERIMENT

The measurements of the partial pressures of the Si$_7$ and Si$_8$ clusters under equilibrium conditions were performed with a Nuclide Corporation 12-90 HT single focusing magnetic deflection type mass spectrometer. Details of the instrument and experimental procedure have been described elsewhere.$^{60}$ Semiconductor grade silicon powder and a small amount of silver wire were contained into a boron nitride (BN) liner, that was placed inside a graphite Knudsen cell.

The measurements were performed in two subsequent parts, series 1 and 2, under different focusing and alignment conditions. The energy of the ionizing electrons was 18 eV for series 1, and 18 and 13 eV for series 2. The last measurement of series 1 at 1993 K was carried out with 11 eV. The filament emission current was 1 mA, and the accelerating potential was 4.5 kV. The ionic species Si$_7^+$, Si$_5^+$, and Si$_4^+$ were identified by their mass-to-charge ratios and isotopic abundance. At each measurement a movable slit was interposed into the molecular beam to distinguish between ions produced from species in the beam and from residual gases with the same mass-to-charge ratio in the ionization region of the mass spectrometer. The ion currents of Si$_7^+$ and Si$_8^+$ were too small for obtaining the respective ionization energies. Table III lists the measured ion currents of the most abundant isotope of the species pertinent to this investigation. Each measurement at 18 eV of the ion intensity of Si$_7^+$.
TABLE I. Optimized geometries (bond lengths in Å), vibrational frequencies (in cm⁻¹), and zero-point energies (in kJ mol⁻¹) for the Si₈ cluster computed at the B3LYP/6-31+G*, HF/6-31G*, and MP2/6-31G* levels of theory.

<table>
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<th>Species</th>
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<th>Vibrational frequencies</th>
<th>Zero-point energies</th>
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<td>224</td>
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<td>299</td>
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<td>a₁</td>
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</tbody>
</table>

*This value is scaled by 0.893.

has been corrected for a contribution due to N₂ coming from the BN liner. The correction has been done by using the measured ion current of ²⁸Si⁺ and ²⁸N₂⁺ and their known isotopic abundances. An example is given from the measurement at 1985 K where the ratio of ²⁸N₂⁺ to ²⁸Si⁺ is 5.01 using 18 eV.

The pressure constant for Si, k(Si), was determined by comparing the corrected ion intensities of Si⁺ to the equilibrium partial pressure of Si (Ref. 71) over condensed silicon. The relationship employed is k(Si) = μ(Si)/[I(Si⁺)]. The pressure calibration constants for Si₇ and Si₈ were then evaluated from k(Si₈) = k(Si)μ(Si)(γ(Si) / [σ(Si₈)n(Si₈)γ(Si₈)]), where σ, n, and γ are the ionization cross section, isotopic abundance, and multiplier gain, respectively. The value of γ(Si₈) was assumed to be equal to that of γ(Si), implying cancellation of the mass and molecular effects. The ionization cross sections of Si₇ and Si₈ were calculated assuming σ(Si₈) = 0.75 × n × σ(Si). For series 1 the resulting pressure constants, in bar A⁻¹ K⁻¹, are at 18 eV, 5.42, 1.68, and 1.59, for Si, Si₇, and Si₈, respectively; at 11 eV, 146.2 and 45.3 for Si and Si₇. For series 2 the resulting pressure constants, in bar A⁻¹ K⁻¹, are for Si, Si₇, and Si₈: at 18 eV, 291.1, 9.02, and 8.56; at 13 eV, 66.9, 20.7, and 19.7, respectively. The uncertainty of k is estimated to be about 30%.

IV. RESULTS AND DISCUSSION

A. Thermal functions

The Gibbs energy functions, (G¹⁰⁻H¹⁰/|T|)GEF₀, and the heat content functions, (H¹⁰⁻H¹⁰/|T|)GEF₀, needed in the evaluation of the reaction enthalpies were taken from literature for Si.⁷¹ Those for Si₇ and Si₈ were calculated according to statistical thermodynamic procedures, using the harmonic oscillator-rigid rotator approximation,⁷² and experimental and/or theoretical molecular parameters.

The Si₇ ground state, ¹A₁, is a pentagonal bipyramid (D₅h) with the equatorial lengths equal to 2.48 Å (×3), and the equatorial-axial lengths equal to 2.47 Å (×3). This structure has a very compressed geometry with the apex atoms being only 2.51 Å apart from each other.¹⁶ The vibrational frequencies, in cm⁻¹, used in this evaluation are: 188 (×2) (e₁), ²³ 221 (×2) (e₂), ¹³ 249 (a₂), ¹³ 289 (×2) (e₂), ₁₆ 340 (×2) (e₁), ¹₆ 340 (×2) (e₂), ₁₆ 358 (a₁), ₁₆ 421 (×2) (e₁), ¹₃ 435 (a₁). ¹₆

TABLE II. Total energies (in hartree) and binding energies (in kJ mol⁻¹) for the Si atom and Si₈ cluster computed at the B3LYP/6-31+G*, G2/MP2, and G2 levels of theory.

<table>
<thead>
<tr>
<th>Species</th>
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<th>G2(MP2)</th>
<th>G2</th>
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<tr>
<td>Si⁷ [P]</td>
<td>-289.372 861</td>
<td>-288.930 014 2</td>
<td>-288.933 242 8</td>
</tr>
<tr>
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<td>-2.312.464 205 1</td>
<td>-2.312.484 786 4</td>
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<tr>
<td></td>
<td>2307</td>
<td>2660</td>
<td>2646</td>
</tr>
<tr>
<td></td>
<td>(23.91)⁸</td>
<td>(27.57)</td>
<td>(27.43)</td>
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</table>

⁸The binding energy is corrected for the ZPE.

⁹The value in parentheses is in eV.
et al. uncertainty is the overall error, calculated as in Schmude Chatillon. 56 reported seven measurements in the temperature data. The results are listed in Table III.

The third-law evaluation was not reliable due to the limited number of log(\(T^6\)) versus 1/\(T\) data. The reference pressure is 1 bar. The levels of theory stipulated in the G2 method were used for Si 7 and Si 8 clusters. The reference pressure is 1 bar.

For Si 8 the structure and molecular parameters computed by the levels of theory stipulated in the G2 method were used as listed in Table I.

Table IV lists the thermal functions calculated for Si 7 and Si 8. The small decrease in the activity of the silicon due to solution of some carbon in the liquid silicon at the high temperatures, observed by Chatillon, 56 was deemed to be within the error limits of the ion current measurements. The pressure constant for Si 7 was evaluated using the same procedure above described in the experimental section. Employing the Gibbs free energy functions for Si 7 and Si used in this investigation, an average third-law \(\Delta_f H_f^0\) for Si 7 was calculated as (2373.8 ± 7.9) kJ mol⁻¹, where the error is the standard deviation. Chatillon’s corresponding second-law value, when corrected to 0 K reference temperature, becomes (2359.8 ± 83) kJ mol⁻¹, in agreement with the third-law value. Similarly we have evaluated the experimental relative ion intensities of Si and Si 7 from Honig 8 at 1660 K by the third-law method, yielding a value of \(\Delta_f H_f^0(Si_7,g)\) = (2438 ± 70) kJ mol⁻¹. This value agrees within the error limits with that from the present investigation, but it has not been taken into account in our selection of the final value for \(\Delta_f H_f^0(Si_7,g)\) because it was obtained under Langmuir conditions of vaporization.

The selected value for the atomization energy of Si 7 was obtained as the weighted average of the experimental third-law values achieved in this investigation and from Chatillon’s analyzed data. The weight for each value was taken as the square root of the number of data points. The resulting \(\Delta_f H_f^0(Si_7,g)\) is (2380.7 ± 36) kJ mol⁻¹. Here the uncertainty is the overall uncertainty calculated from the estimated uncertainties as reported in Ref. 59.

The enthalpies of formation of Si 7 and Si 8 have been obtained from the present atomization energies and the enthalpy of vaporization of Si 7 from Gurvich et al. 71 assuming unit activity of the liquid silicon.

The enthalpy of the atomization reaction,

\[ \Delta_f H_f^0 = n \text{Si(g)} \to n \text{Si} + n \text{Si} \text{ions} \]

was evaluated according to the third-law method, using the relation \(\Delta_f H_f^0 = -RT \ln K_p - T \Delta \ln (G_f^0^o - H_f^0)/T\). A second-law evaluation was not reliable due to the limited number of data. The results are listed in Table III.

Averaging the measured atomization enthalpies, in kJ mol⁻¹, for Si 7 and Si 8 yields \(\Delta_f H_f^0(Si_7,g) = 2387.2 ± 13.6\) and \(\Delta_f H_f^0(Si_8,g) = 2735.4 ± 13.6\), where the errors are standard deviations. The recommended value for the atomization energy of Si 8 is (2735 ± 65) kJ mol⁻¹. Here the uncertainty is the overall error, calculated as in Schmude et al. 59.

We have also used the data by Chatillon 56 to carry out a third-law evaluation for the atomization reaction of Si 7. Chatillon 56 reported seven measurements in the temperature range 1910–2140 K, and derived a second-law value of \(\Delta_f H_f^0(298.15)\) = (2377 ± 83) kJ mol⁻¹ for reaction (1). We determined the ion intensities of Si 7 and Si 8² from his plots of log(\(I^2\)) versus 1/\(T\). The pressure constant k(Si) was obtained by comparing the ion intensities of Si 7 with the partial pressures of Si from Gurvich et al. 71 assuming unit activity of the liquid silicon.

The enthalpies of formation of Si 7 and Si 8 have been obtained from the present atomization energies and the enthalpy of vaporization of Si 7 from Gurvich et al. 71 assuming unit activity of the liquid silicon.
enthalpy of sublimation for silicon from Gurvich et al.,71 employing the relation \( \Delta_f H^0(Si) = n \Delta_f H^0(Si) - \Delta_f H^0(Si_n) \), where \( T = 0 \) or 298.15 K. The thermodynamic properties for Si\(_7\) and Si\(_8\) clusters have been summarized in Table V.

With the standard enthalpy of formation of atomic silicon, \( \Delta_f H^0(Si) = (455.6 \pm 4.2) \text{ kJ mol}^{-1} \), from Hultgren et al.,24 the standard enthalpies of formation, \( \Delta_f H^0(Si_n, g) \), for the Si\(_7\) and Si\(_8\) clusters, in kJ mol\(^{-1}\), become 783.35 and 887.65, respectively. With the standard enthalpy of formation of silicon, \( \Delta_f H^0 = (445.3 \pm 5.0) \text{ kJ mol}^{-1} \), from Rocabois et al.,75 the values for \( \Delta_f H^0(Si_n, g) \), in kJ mol\(^{-1}\), result in 711.35 for Si\(_7\) and 804.65 for Si\(_8\). Evidently, the choice of the enthalpy of sublimation of silicon makes a significant difference on the \( \Delta_f H^0(Si_n, g) \) values.

It is worth comparing the atomization enthalpies of \( Si_n(n = 2-6) \) obtained from the enthalpies of formation of \( Si_n(n = 2-6) \) determined by Rocabois et al.,57 and \( \Delta_f H^0(Si, g) \) from Gurvich et al.,71 with the values obtained in our laboratory. \( \Delta_f H^0(Si_n, g) \) values, in kJ mol\(^{-1}\), from our laboratory and from Rocabois et al.,57 respectively, are Si\(_2\), 319.0 \pm 7.0 (Ref. 58) and 311.2 \pm 9.4;77 Si\(_1\), 705 \pm 16 (Ref. 58) and 696.8 \pm 7.9;77 Si\(_4\), 1151 \pm 22 (Ref. 58) and 1133.4 \pm 8.3;57 Si\(_5\), 1559 \pm 24 (Ref. 60) and 1548.3 \pm 10.3;57 Si\(_6\), 1981 \pm 32 (Ref. 61) and 1949.8 \pm 18.3.57 The values from these independent studies agree within the given error limits.

From the \( \Delta_f H^0 \) values, the fragmentation energies or incremental dissociation energies, \( \Delta_f H^0(Si_n) - \Delta_f H^0(Si_{n-1}) \), can be derived. Large values of fragmentation energies, defined as the minimum energy required removing an atom from the cluster, imply a higher stability than neighboring clusters containing one more or one less atom. The obtained fragmentation energies are, in eV, 3.86 and 4.18 for Si\(_7\) and Si\(_8\), respectively. In arriving at the fragmentation energy of Si\(_7\) the value for the atomization energy of Si\(_6\), \( \Delta_f H^0(Si_6, g) = (20.53 \pm 0.06) \) (Ref. 61) eV was used.

These values together with the mass spectrometric incremental dissociation energies of the silicon clusters containing from 3 to 6 atoms can be compared with the fragmentation energy values of the group 14 atomic clusters. The \( \Delta_f H^0 \) values for C\(_n\), Ge\(_n\), and Sn\(_n\) clusters are taken from previous investigations: for C\(_n\)(n = 2–7) from Gingerich et al.,62 for Si\(_n\)(n = 2–5) from Ran et al.,60 and for Si\(_4\) from Gingerich et al.;51 for Ge\(_n\)(n = 2–8) from Gingerich et al.;63,76 for Sn\(_n\)(n = 2–3) from Gingerich et al.,67 and for Sn\(_n\)(n = 4–7) from Meloni et al.64 In Fig. 2 the fragmentation energies of group 14 atomic clusters are plotted versus the number of atoms. The trend of the incremental dissociation energies is similar for Si, Ge, and Sn clusters, showing a higher stability for the even-numbered atom clusters, especially those with four atoms. This behavior is different from that for the carbon clusters, where the enhanced stability of odd-numbered carbon clusters is due to completely filled \( \sigma \) molecular orbitals. Small carbon clusters exhibit chain or ring structures, while silicon, germanium, and tin clusters with five to eight atoms show more complex polyhedral structures.

It is also interesting to calculate the binding energies, or atomization enthalpies, of silicon clusters anions for the reaction \( Si_n(g) = (n - 1)Si(g) + Si^-(g) \), using the experimental values of their electron affinities (EA) and the values for the atomization energies of the neutral clusters from our laboratory. The results, in eV, are 8.21 for Si\(_3\), 12.67 for Si\(_4\), 17.36 for Si\(_5\), 20.84 for Si\(_6\), 25.13 for Si\(_7\), and 29.05 for Si\(_8\). The relation used is \( \Delta_f H^0(Si_n) = \Delta_f H^0(Si_{n-1}) - EA(Si) + EA(Si_n) \). The experimental electron affinities (in eV) were taken from Scheer et al.78 for the atomic silicon (1.389 521 \pm 0.000 020), from Xu et al.15 for Si\(_3\) (2.29 \pm 0.02), Si\(_4\) (2.13 \pm 0.01), Si\(_5\) (2.59 \pm 0.02), and Si\(_7\) (1.85 \pm 0.02), and from Kishi et al.57 for Si\(_6\) (2.00 \pm 0.03) and Si\(_8\)

![Figure 2. Fragmentation energies, \( \Delta_f H^0(X_n) - \Delta_f H^0(X_{n-1}) \), of the group 14 atomic clusters vs the cluster size (n).](image)

**TABLE VI.** A comparison of experimental atomization energies, in eV, for Si\(_7\) and Si\(_8\) clusters with theoretical values.

<table>
<thead>
<tr>
<th>Species</th>
<th>Experiment</th>
<th>MP4</th>
<th>PW/VWN</th>
<th>PWB</th>
<th>INTB*</th>
</tr>
</thead>
<tbody>
<tr>
<td></td>
<td>This investigation</td>
<td>MP4a</td>
<td>Corr. a</td>
<td>GVB-ECPb</td>
<td>DFc</td>
</tr>
<tr>
<td>Si(_7)</td>
<td>24.67 \pm 0.37</td>
<td>22.16</td>
<td>26.60</td>
<td>13.86</td>
<td>24.91</td>
</tr>
<tr>
<td>Si(_8)</td>
<td>28.35 \pm 0.67</td>
<td>24.31</td>
<td>29.20</td>
<td>14.72</td>
<td>28.01</td>
</tr>
</tbody>
</table>

*Reference 19.
Reference 21.
Reference 23.
Reference 50.
Reference 27.
Reference 28.
Reference 29.
Reference 31.
Reference 32.
(2.09±0.15). Xu et al.\textsuperscript{15} did not measure the EA's of Si\textsubscript{8} and Si\textsubscript{9}, whereas Kishi et al.\textsuperscript{67} determined the EA values for Si\textsubscript{n}(n=4–11).

C. Comparison of experimental and theoretical atomization energies

During the years many theoretical methods have been improved in predicting binding or atomization energies of small group 14 clusters, especially those of carbon and silicon, with chemical accuracy.\textsuperscript{69} One of the most reliable theoretical methods for such small clusters is the G2 theory.

In Tables VI and VII we compare the experimental atomization energies of Si\textsubscript{7} and Si\textsubscript{8} clusters obtained in the present investigation with the corresponding theoretical values.

Raghavachari and Rohlfing\textsuperscript{19} performed fourth order Møller–Plesset (MP4) calculations on Si\textsubscript{7}. The corrected MP4 binding energies, obtained by multiplying the MP4 values by an empirical scale factor of 1.2, due to their underestimation of the binding energies of Si\textsubscript{2} and Si\textsubscript{3}, are slightly higher than our experimental atomization energies. Patterson and Messmer\textsuperscript{21} carried out \textit{ab initio} generalized-valence-bond (GVB) calculations with an effective core-potential (ECP). Although they obtained the optimized ground state geometries for Si\textsubscript{7} and Si\textsubscript{8} clusters in agreement with the accepted structures, their binding energies values are considerably lower when compared with the other theoretical results in the literature. Fournier \textit{et al.}\textsuperscript{22} reported the equilibrium geometry, vibrational frequencies, and atomization enthalpies for the ground state obtained with the linear combination of Gaussian-type atomic orbitals-density functional (LCGO-DF) method, using the local spin density (LSD) potential of Vosko, Wilk, and Nusair (VWN), and Perdew–Wang (PW) gradient corrected functional. Shvartsburg \textit{et al.}\textsuperscript{20} in similar calculations, used a Perdew–Wang–Becke (PWB) gradient corrected functional. The \(\Delta_a\) values obtained in this investigation are those calculated by Tománek and Schlüter,\textsuperscript{22} but the Si\textsubscript{7} geometry they calculated is a capped octahedron. The other TB variants, nonorthogonal tight-binding (NTB),\textsuperscript{28} improved nonorthogonal tight-binding (INTB),\textsuperscript{29} tight-binding molecular dynamics (TBMD),\textsuperscript{31} fractional bond tight-binding (FBTB),\textsuperscript{32} and the quantum Monte Carlo (QMC) method with the local density approximation (LDA) (Ref. 48) give higher values than the experimental results. With the FBTB (Ref. 32) model the lowest energy Si\textsubscript{8} structure is a distorted bicapped octahedron, which is capped on adjacent faces, whereas \textit{ab initio} calculations indicate that the most favorable arrangement corresponds to capping two opposite faces. Wei \textit{et al.}\textsuperscript{37} calculated \(\Delta_a\) values higher than our experimental values performing LSD-MD calculations with the exchange-correlation (xcg) gradient correction. Eguchi \textit{et al.}\textsuperscript{40} obtained almost the same as the experimental value for \(\Delta_a\) using the LDA and the Becke–Lee–Yang–Parr (BLYP) functional. Bolding and Anderson\textsuperscript{46} using an interatomic potential functional (IPF) determined \(\Delta_a\) slightly lower than the experimental values. Grossman and Mitáš\textsuperscript{60} using diffusion Monte Carlo (DMC) method showed that the binding energy for Si\textsubscript{7} calculated with this method agrees within about 3% with experiment. The G2 values for Si\textsubscript{7} (Ref. 69) and Si\textsubscript{8} (present investigation) are in good agreement with the experimental values.

\begin{table}[h]
\centering
\caption{A comparison of computed atomization energies, in eV, for Si\textsubscript{7} and Si\textsubscript{8}.}
\begin{tabular}{|c|c|c|c|c|c|c|c|}
\hline
Species & LSD-MD-xcg\textsuperscript{a} & LDA-BLYP\textsuperscript{b} & IPF\textsuperscript{c} & QMC-LDA\textsuperscript{d} & DMC\textsuperscript{d} & B3LYP\textsuperscript{e} & G2 \textsuperscript{(MP2)} & G2 \textsuperscript{(MP2)} \\
\hline
Si\textsubscript{7} & 27.46 & 24.78 & 23.84 & 28.98 & 24.01 & \cdots & 24.95 \textsuperscript{f} & \cdots \\
Si\textsubscript{8} & 30.89 & \cdots & \cdots & 27.98 & \cdots & 23.91 & 27.57 \textsuperscript{g} & 27.43 \\
\hline
\end{tabular}
\end{table}

\textsuperscript{a}Reference 37.
\textsuperscript{b}Reference 40.
\textsuperscript{c}Reference 46.

\textsuperscript{f}This investigation.
\textsuperscript{g}Reference 69.

\textsuperscript{17}K. Raghavachari and V. Logovinsky, Phys. Rev. Lett. 55, 2853 (1985).

ACKNOWLEDGMENTS

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